



500.41316VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAJI, et al
Serial No.: ~~10/090,750~~
10/659,394
Filed: September 11, 2003
For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS
AND PLASMA PROCESSING METHOD USING IT
Group: 1763
Examiner: P. Hassanzadeh

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Non-Fee Response
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 22, 2004

Sir:

In response to the Notice of Non-Compliant Amendment dated March 17, 2004, applicants submit herewith a complete listing of the claims for the above-identified application.

Listing of the Claims; and

Remarks are included following the listing.